



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

KAWAGUCHI et al

EXPEDITED PROCEDURE

December 16, 2004

Serial No.:

10/083,252

**BOX AF** 

Filed:

February 27, 2002

For:

Plasma Processing Method And Apparatus

Art Unit:

1763

Examiner:

P. Hassanzadeh

## PETITION FOR AN EXTENSION OF TIME

Mail Stop: Box AF (Fee) Commissioner For Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application, applicants hereby respectfully petition for an extension of time to permit the filing of a response within the second month subsequent to the expiration of the shortened statutory period set in the outstanding Office Action mailed July 16, 2004.

A payment in the amount of \$450.00 to cover the fee required for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 500.41295X00).

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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